

Notice of References Cited

Application/Control No.

09/236,113

Applicant(s)/Patent Under
Reexamination
SHI ET AL.

Examiner

Gregg Cantelmo

Art Unit

1753

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U.S. PATENT DOCUMENTS

*		Document Number	Date	Name	Classification	
		Country Code-Number-Kind Code	MM-YYYY			
	A	US-6,103,074	08-2000	Khominich	204	298.41
	B	US-				
	C	US-				
	D	US-				
	E	US-				
	F	US-				
	G	US-				
	H	US-				
	I	US-				
	J	US-				
	K	US-				
	L	US-				
	M	US-				

FOREIGN PATENT DOCUMENTS

*		Document Number	Date	Country	Name	Classification	
		Country Code-Number-Kind Code	MM-YYYY				
	N	0 495 447 A1	07-1992	Europe		-	-
	O						
	P						
	Q						
	R						
	S						
	T						

NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	V. Semenyuk et al. "Physical and Technological Features of the Arc Vacuum System for Coatings Deposition Based on the Plasma Arc Accelerator", 1996, XVIIth International Symposium on Discharges and Electrical Insulation in Vacuum, pp. 871-875.
	V	
	W	
	X	

*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.